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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Robert Nakayama *et al.*
Title: SENSOR FABRICATING METHOD
Appl. No.: 09/847,885
Filing Date: 05/02/2001
Examiner: Brian K. Talbot
Art Unit: 1762

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.116

Mail Stop BOX AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This communication is responsive to the Final Office Action dated July 2, 2007, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 7 of this document.

Please amend the application as follows: